



Application No. 09/837,552  
Docket No.: 0756-2296

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6-9-03  
Mallin

- 1 -

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Patent Application of )  
Hisashi OHTANI et al. ) Art Unit: 2815  
Serial No. 09/837,552 )  
Filed: April 19, 2001 ) Examiner: N. Drew Richards  
For: SEMICONDUCTOR DEVICE AND )  
MANUFACTURING METHOD )  
THEREOF )

**CERTIFICATE OF MAILING OR TRANSMISSION**

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*April Campbell*  
April Campbell

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**AMENDMENT**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In response to the non-final Office Action dated January 30, 2003, please amend the above-identified application as follows: